



Patent
Attorney's Docket No. 015290-496

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of) Attention: **DRAFTING BRANCH**
)
Duane OUTKA et al.) Group Art Unit: 1746
)
Application No.: 09/820,691) Examiner: Not Yet Assigned
)
Filed: March 30, 2001)
)
For: **METHOD OF REDUCING ALUMINUM**)
 FLUORIDE DEPOSITS IN PLASMA)
 ETCH REACTOR)
)

SUBMISSION OF FORMAL DRAWINGS

Box Issue Fee
Assistant Commissioner for Patents
Washington, D.C. 20231

ATTN: OFFICIAL DRAFTSMAN

Sir:

Enclosed please find eight sheet(s) of formal drawings for review by the Patent and Trademark Office. Should the enclosed drawings require changes, it is respectfully requested that the Patent and Trademark Office notify the undersigned of same.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

By: Peter K. Skiff
Peter K. Skiff
Registration No. 31,917

P.O. Box 1404
Alexandria, Virginia 22313-1404
(703) 836-6620

Date: May 24, 2001